# Engineered mode coupling in high-Q microresonators enables deterministic low-repetition-rate soliton microcombs

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Soliton optical frequency combs have become key enablers for a wide range of applications, including telecommunications, optical atomic clocks, ultrafast distance measurements, dual-comb spectroscopy, and astrophysical spectrometer calibration, many of which benefit from low repetition rates. However, achieving such low-repetition-rate soliton microcombs is nontrivial as long cavities require substantially higher pump power, which induces stronger thermal effects that, in turn, exacerbate thermal instability and complicate access to stable soliton states. The dual-mode pumping scheme, in which a continuous-wave pump couples to both the comb-generating mode and an auxiliary mode, has proven simple and effective for mitigating thermal instability and enabling thermally accessible soliton generation. Yet, in long-cavity devices, the standard bus-to-resonator coupling conditions for these two modes diverge substantially, resulting in insufficient pump coupling to the auxiliary mode, which makes dual-mode pumping particularly challenging for low-repetitionrate microcombs. In this work, we overcome this limitation by coupling the pump to the auxiliary mode via inter-modal coupling, which can be introduced in racetrack microresonators and engineered by tailoring the cavity bend design. We validate this approach in a high-Q  $(>10^7)$  silicon nitride microresonator and demonstrate thermally accessible, deterministic single-soliton generation at a repetition rate of 33 GHz. This work provides a simple and robust pathway for generating low-repetition-rate soliton microcombs.

### I. INTRODUCTION

The chip-based optical frequency comb is revolutionizing various aspects in classical and quantum applications since it offers the prospect of lowering size, weight, and power (SWaP) and integration possibilities with other devices for large-volume semiconductor manufacturing [1-6]. For many of these emerging applications, chip-based frequency combs with low-repetitionrates are highly desirable because they provide densely spaced, coherent comb lines. In coherent optical communication systems, for instance, dense wavelength division multiplexing (DWDM) technique relies on closely spaced wavelength channels to increase data transmission capacity [7–9]. The recent experiment results show that microcombs serve as viable multi-wavelength sources for ultra-long-haul optical transmission, achieving performance comparable to conventional laser arrays over transmission distances exceeding 8000 km [10, 11]. Beyond optical communications, low-repetition-rate microcombs have also attracted considerable interest in dual-comb spectroscopy [12], astrophysical spectrometer calibration [13], low-noise microwave generation [14– 16], and narrow-linewidth laser synthesis [17]. Therefore, tremendous effort has been devoted to developing various integrated platforms, including Si [18], Si<sub>3</sub>N<sub>4</sub> [19, 20], Hydex [21], diamond [22], AlN [23, 24], AlGaAs [25, 26], LiNbO<sub>3</sub> [27, 28], GaP [29], GaN [30, 31], and SiC [32–34]. However, a fundamental challenge in realizing soliton microcombs arises from thermal effects, as stable operation requires all comb modes to reside on the red-detuned side of their resonances, which is an intrinsically unstable regime.

Therefore, several techniques have been developed to overcome the thermal effects in soliton generation. The first relies on dispersion and cavity-length design to mitigate the issue in a single-cavity, single-pump system, but the method is highly dependent on the free spectral range (FSR) and has so far been demonstrated only for microcombs with THz repetition rates [35, 36]. The second focuses on rapid control of the pump laser, faster than the thermal response time (on the ms scale), to bypass thermal instabilities. For example, fast frequency sweeping and single-sideband suppressed-carrier modulation with scan speeds up to 100 GHz/ $\mu$ s have been demonstrated for single soliton generation [20, 37]. Power kicking has also been successfully employed for single-soliton excitation [38]. However, these methods introduce additional complexity, as they require extra equipment or active electronic control loops. The third category involves thermal management techniques that mitigate resonance shifts. Such approaches typically employ an auxiliary laser to counteract thermal shift of the pump resonance, at the expense of an additional laser source [36, 39, 40], or utilize another spatial mode within the cavity to provide passive thermal stabilization [41–43]. The latter is also known as the dual-mode pumping scheme, in which the fundamental mode and the auxiliary mode are used for soliton generation and thermal compensation, respectively. Nonetheless, this approach has so far been limited to large-repetition-rate

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devices [41–43]. Additionally, external tuning via microheaters is necessary to precisely control the relative positions of the two modes for effective thermal compensation. Extending this approach to low-repetition-rate soliton microcombs is significantly more challenging due to the increased threshold power required for soliton formation and the induced much stronger thermal instability, necessitating more efficient thermal compensation. However, the conventional point coupler yields negligible coupling efficiency to the auxiliary mode in long cavity configurations, leading to a significantly weaker thermal compensation effect.

Compared to the conventional approach that uses a point bus-to-ring coupler, we propose employing a racetrack microresonator and engineering curved sections with Euler bends, which feature a smooth transition from an infinite radius to a finite minimum radius. While Euler bends are typically employed to suppress higherorder modes [44, 45], the intermodal coupling can arise when the minimum radius is sufficiently small [46]. This coupling originates from the rapid variation in curvature, which induces mode mismatch between the straight and bent waveguide sections. Nevertheless, the resulting mode coupling remains substantially weaker than that caused by conventional circular bends. Moreover, the mode coupling introduced here can be precisely controlled, enabling effective thermal compensation without the need for external active tuning.

In this work, we demonstrate thermally accessible and deterministic generation of low-repetition-rate soliton microcombs on the high-quality factor (Q) Si<sub>3</sub>N<sub>4</sub> platform. We designed an all-passive Si<sub>3</sub>N<sub>4</sub> racetrack microresonator to introduce a nearby mode adjacent to the pump resonance, thereby mitigating thermal effects during soliton formation. Leveraging this engineered mode coupling, we achieved thermally accessible and deterministic broadband single-soliton generation at a repetition rate of 33 GHz, covering both the telecommunication C- and L-bands, through manual tuning. Our method provides a straightforward approach for overcoming thermal instabilities in long-cavity microresonators, enabling broadband, low-repetition-rate soliton microcombs.

# II. PRINCIPLE

Figures 1 illustrate the proposed scheme of auxiliary mode introduction for low-repetition-rate soliton microcomb generation. The desired microresonator supports two spatial modes, where the fundamental mode (orange) serves as the mode for soliton generation and the auxiliary mode (green) provides thermal compensation. During soliton formation, the pump laser operates on the red-detuned side of the resonance [47]. Introducing an additional mode may appear counterintuitive, as it can induce avoided mode crossings (AMXs), which are known to hinder soliton formation [48]. Consequently,

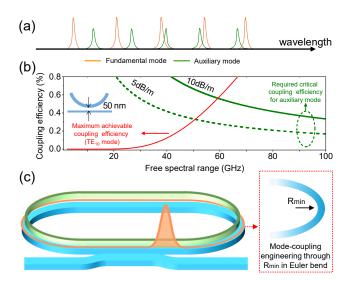


FIG. 1. Proposed scheme of auxiliary mode introduction for low-repetition-rate soliton microcomb generation. (a) Illustration of the desired microresonator supports two modes, where one serves as the fundamental mode for comb generation and the auxiliary mode provides thermal compensation. (b) Auxiliary mode introduction through the conventional point coupler (inset). Green curve: The bus-to-ring coupling efficiency at the critical coupling condition with respect to free spectral range for 10 dB/m and 5 dB/m propagation loss. Red curve: Maximum achievable coupling efficiency for the TE<sub>10</sub> mode under a point coupler with a bus-to-ring gap of 50 nm. (c) The proposed soliton generation scheme in a device configuration of a racetrack microresonator consists of straight and bent waveguides. The soliton is generated in the fundamental mode (orange), and the auxiliary mode (green) is used for thermal compensation. Dashed red box: mode coupling is introduced through engineering the curved section of the racetrack microresonator.

many advanced designs aim to suppress higher-order modes to preserve single-mode operation [44, 45, 49–52]. However, recent studies have demonstrated that coupling an auxiliary mode can mitigate thermal effects and enable soliton microcomb generation via manual tuning [41-43].

Conventionally, a point coupler is used (inset in Fig. 1(b)) [42, 43] to couple a fraction of power from the fundamental mode in the bus to auxiliary mode in the ring waveguide. Thus, a microheater is necessary to tune these two modes for effective thermal compensation. Although effective in short cavities, this approach becomes difficult to implement in long cavities, where the need for efficient thermal compensation is not met by the limited bus-to-ring coupling to the auxiliary mode in practice. The green curves in Fig.1(b) plot the required bus-to-ring coupling efficiency under critical coupling conditions for the auxiliary mode with 10 dB/m and 5 dB/m propagation loss, respectively. It is worth noting that the Si<sub>3</sub>N<sub>4</sub> waveguide dimension for calculation is 765 nm  $\times$  2  $\mu$ m, consistent with the value used

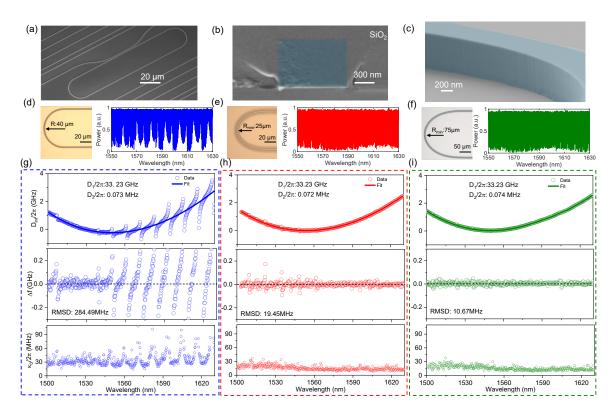


FIG. 2. Mode coupling engineering in multimode racetrack resonators. Scanning electron microscopy (SEM) image of the fabricated (a) racetrack microresonator, (b) its cross-section, and (c) sidewall. Proposed mode coupling engineering through (d) circular bends with 40  $\mu$ m radius and Euler bends with minimum bending radius (R<sub>min</sub>) of (e) 25  $\mu$ m and (f) 75  $\mu$ m at curved sections. Left: optical microscope. Right: Transmission spectrum. (g, h, i) Corresponding linear characterization. First row: measured and fitted integrated dispersion (D<sub>int</sub>/2 $\pi$ ). Second row: Resonance frequency deviation ( $\Delta$ f) from the fitted curve, which reflects the mode coupling strength induced to the TE<sub>00</sub> mode. Third row: Intrinsic linewidth ( $\kappa$ <sub>0</sub>/2 $\pi$ ) distribution across a broad wavelength range.

in our experiment. The red curve shows the maximum achievable coupling efficiency with a bus-to-ring gap distance of 50 nm, where the auxiliary mode here is selected to be the  $\mathrm{TE}_{10}$  mode. Consequently, introducing an additional spatial mode via a conventional point coupler becomes impractical, as the auxiliary mode can hardly provide thermal compensation due to the negligible coupling efficiency at a small FSR. Moreover, the point coupler inherently reduces coupling ideality, leading to parasitic losses [53].

Figure 1(c) shows the principle of soliton generation with a low-repetition rate, where the soliton is generated in the fundamental mode (orange), and the auxiliary mode (green) is used for thermal compensation. The dashed red box in Fig. 1(c) illustrates the proposed approach for achieving controllable, engineered mode coupling by tailoring the curved section of a racetrack microresonator. In this design, the curved waveguide can adopt an Euler bend with various minimum bending radii ( $R_{\rm min}$ ). In contrast to conventional applications where Euler bends are employed to suppress higher-order modes [44, 45], this work intentionally utilizes Euler bends with carefully engineered minimum radii to induce controllable intermodal coupling strength

for effective thermal mitigation during low-repetitionrate soliton microcomb generation.

### III. RESULTS

## A. Device design and linear characterization

We propose to use a racetrack microresonator, which consists of both straight and curved waveguide sections. To preserve high coupling ideality, the bus and ring waveguides are designed to have identical dimensions, where the coupling is achieved through a certain coupling length. The engineered mode coupling is realized by tailoring the curved sections of the racetrack microresonator, which can feature either circular or Euler bends. Previous studies have shown that racetrack microresonators with Euler bends can suppress intermodal coupling. However, in such cases, the complete suppression of mode coupling eliminates the possibility of thermal compensation. Thus, we demonstrate that by carefully engineering the R<sub>min</sub> of the Euler bend, controlled mode coupling can be achieved. We designed three Si<sub>3</sub>N<sub>4</sub> racetrack microresonators with multimode

waveguide width (765 nm  $\times$  2  $\mu$ m) to intentionally introduce an auxiliary mode for mitigating thermal effects during soliton microcomb generation. To evaluate the proposed mode-coupling engineering approach, we fabricated both circular and Euler-bend racetrack microresonators on the Si<sub>3</sub>N<sub>4</sub> platform using a subtractive process [54-56]. A 765-nm-thick  $Si_3N_4$  layer was deposited on a silicon substrate with a thermally grown silicon dioxide buffer via low-pressure chemical vapor deposition. Device patterns were defined using optimized electron-beam lithography [57] and transferred into the Si<sub>3</sub>N<sub>4</sub> film via inductively coupled plasma reactive ion etching. The structures were then cladded with silicon dioxide. Figures 2(a, b, c) show the scanning electron microscopy (SEM) image of the fabricated racetrack microresonator, its cross-section and sidewall, respectively.

The left panels of Figs. 2(d, e, f) show that the circular-bend resonator features a fixed bending radius of 40  $\mu$ m, while the Euler-bend resonators have R<sub>min</sub> of 25  $\mu$ m and 75  $\mu$ m. All devices have a cavity length of 4.36 mm, corresponding to an FSR of 33 GHz. The right panels of Figs. 2(d, e, f) present the measured transmission spectra of the three designs. The circular-bend resonator exhibits pronounced spectral modulation, while the Euler-bend designs show much smoother transmission, indicating weaker intermodal coupling. This difference is further confirmed in the first row of Figs. 2(g, h, i), which display the measured and fitted integrated dispersion  $D_{\rm int} = \sum \mu^n/(n!)D_n$ , where  $D_n$  denotes the  $n^{\rm th}$ -order dispersion coefficient. The similar secondorder dispersion  $(D_2/2\pi)$  values among all devices confirm consistent waveguide dimensions. However, it is difficult to distinguish based on  $D_{\rm int}$  alone in two Euler-

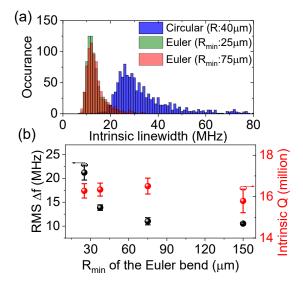


FIG. 3. Linewidth and frequency deviation measurement. (a) Resonance linewidth characterization of racetrack microresonators with different bend designs. (b) Root-mean-square frequency deviation  $(\Delta f)$  and intrinsic Q measurement in Euler bend with different minimum bending radius  $(R_{\min})$ .

bend designs. Therefore, the second row of Figs. 2(g, h, i) plot the resonance frequency deviation from the fitted curve, highlighting the AMX-induced mode shifts of the  $TE_{00}$  mode and the effective mode-coupling strength. The circular-bend resonator exhibits the strongest deviation, with a root-mean-square deviation (RMSD) of 284.49 MHz. The periodicity of the spectral modulation indicates coupling between the  $TE_{00}$  and  $TE_{10}$ modes, arising from modal mismatch between straight and bent sections. In contrast, the Euler-bend resonators show reduced coupling strength, which can be adjusted by  $R_{\min}$ . The smaller  $R_{\min}$  exhibits weak modulation (RMSD 19.45 MHz), while the larger  $R_{min}$  shows almost complete suppression (RMSD 10.67 MHz). Besides, it confirms that mode coupling in Euler bend design remains substantially weaker than that induced by conventional circular bends. Finally, the third row of Figs. 2(g, h, i) compare the intrinsic linewidth  $\kappa_0/2\pi$ distributions across a broad wavelength range. In the circular bending design, strong mode coupling around the AMXs leads to severe Q-factor (large  $\kappa_0/2\pi$ ) degradation. In contrast, the Euler-bend designs enable controlled mode coupling while preserving high Q performance. Notably, the entire device footprint can be as small as  $0.15 \text{ mm}^2$ .

To verify that high Q performance is preserved even in Euler bends with a small minimum bending radius, Fig. 3(a) presents histograms of the intrinsic linewidths for the three designs. The most probable linewidths for the circular bend and the Euler bends with minimum radii of 25  $\mu$ m and 75  $\mu$ m are 26 MHz, 12 MHz, and 11.5 MHz, respectively, corresponding to intrinsic Q factors of  $7.5 \times 10^6$ ,  $16.25 \times 10^6$ , and  $16.95 \times 10^6$ . These results confirm that the high-Q performance is maintained even with the introduction of weak mode coupling. Fig. 3(b) shows that the mode coupling strength can be tuned with respect to the minimum bending radius in the Euler-bend design, with the frequency deviation varying from approximately 21 MHz to 10 MHz while high Q performance is maintained.

# B. Low-repetition-rate soliton microcomb generation

As discussed in the Section.1, thermally accessible low-repetition-rate soliton microcomb favors microresonators with an appropriate mode-coupling strength. Therefore, the design in Fig. 2(e) is employed for the experiment since it enables weak intermodal coupling while maintaining high Q performance. We first identify a  $TE_{00}$  resonance that is weakly coupled to a nearby higher-order  $TE_{10}$  mode located on the red-detuned side. This configuration provides thermal compensation when the pump laser is tuned across the resonance. The experimental setup is shown in Fig.4 (a). A continuous-wave (CW) pump, amplified by an erbium-doped fiber amplifier, is coupled to the  $TE_{00}$  mode of the  $Si_3N_4$  device. In

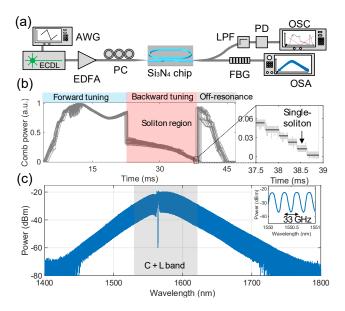


FIG. 4. Low-repetition-rate soliton microcomb generation. (a) Schematic drawing of the experimental setup. AWG: arbitrary waveform generator, ECDL: External Cavity Diode Laser, PC: Polarization Controller, EDFA: Erbium-Doped Fiber Amplifier, LPF: Long-pass filter, PD: Photodetector, OSC: oscilliscope, FBG: Fiber Bragg Grating, OSA: Optical Spectrum Analyzer. (b) Plot of 20 overlaid experimental traces of the output comb power (gray) in the pump forward (blue) and backward tuning (red) over the resonance with the same pump power and tuning speed. The right panel shows the magnified view of the backwards tuning with successive switching of soliton states. (c) The optical spectrum of a broadband single soliton comb with a repetition rate of 33 GHz, where the pump is filtered by a FBG.

the output, the comb power and spectrum are recorded by an oscilloscope and an optical spectrum analyzer, respectively. Figure 4(b) shows 20 overlaid traces of the transmitted comb power (gray) during forward (blue) and backward tuning (red), recorded with the same onchip pump power of 630 mW and a tuning speed of 100 GHz/s, indicating a deterministic single-soliton generation. In practical operation, soliton states can be consistently accessed through a manual tuning of the pump wavelength. The blue and red shaded regions denote laser operation on the blue- and red-detuned sides of the resonance, respectively, while the gray region marks the off-resonant regime. The right panel of Fig. 4(b) presents a magnified view of the backward tuning trace, showing successive transitions from multiple to single soliton states.

The optical spectrum of the single-soliton microcomb is shown in Fig. 4(c), where the pump light is suppressed by a fiber Bragg grating. The spectrum spans approximately 300 nm, from 1450 nm to 1750 nm, with a repetition rate of 33 GHz (inset). The C- and L-band regions are shaded in gray and have more than 300 comb lines exhibiting power levels exceeding -30 dBm. It can be

particularly interesting for ultra-long-haul optical transmission employing the DWDM technique [11]. For such systems, it is desirable to generate a densely spaced microcomb covering the C- and L-bands, with each comb line exceeding -30 dBm. The recent studies demonstrate that, after 8000 km of transmission, the signalto-noise ratio (SNR) difference between a commercial WDM laser bank and a microcomb source with -30 dBm input power is negligible [10]. The required microcomb source demands operating power substantially exceeding the threshold power to reach the target bandwidth and required comb-line power, while the increased intracavity power exacerbates thermal instability. As a result, the thermal instability significantly arises, making it difficult to stably access the soliton step. The proposed approach effectively addresses this issue by employing engineered mode coupling to mitigate the thermal effect, enabling deterministic soliton generation through simple manual tuning.

#### IV. CONCLUSION

In summary, we have demonstrated a thermally accessible and deterministic approach for generating low-repetition-rate soliton microcombs on the high-Q silicon nitride platform. By introducing engineered mode coupling through carefully designed Euler bends in racetrack microresonators, we achieved precise control over intermodal interaction while maintaining high-Q performance. This controlled coupling effectively mitigates significant thermal instability during soliton formation under high pump power, enabling deterministic single-soliton generation through simple manual tuning. The resulting soliton microcomb exhibits a repetition rate of 33 GHz and a 300 nm optical bandwidth, covering the entire C- and L-bands with per-line power above -30 dBm, which is ideal for high-capacity coherent communication. The demonstrated results provide a simple and robust solution for realizing broadband, low-repetition-rate soliton microcombs. The proposed method can be extended to other platforms with a large thermo-optic coefficient, paving the way for applications in optical communications, microwave photonics, and precision metrology.

### Availability of data and materials

The datasets generated and/or analyzed during in this study are available from the corresponding authors upon reasonable request.

# Competing interests

The authors declare no competing financial interests.

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